



PATENT
Serial No.: 09/462,912
Docket No.: 29273/516

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPL. NO. : 09/462,912 Confirmation No. 5646
APPLICANTS: Shigeo MORIYAMA, et al.
FILED : January 18, 2000
FOR : POLISHING APPARATUS AND METHOD FOR PRODUCING
SEMICONDUCTORS USING THE APPARATUS
ART UNIT : 3723
EXAMINER : Dung Van Nguyen
DOCKET NO.: 29273/516
CUSTOMER NO.: 23838

MAIL STOP AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

SIR:

As a submission with the attached Request For Continued Examination, please amend the application as follows: